Docket No.

212020US99

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

IN RE APPLICATION OF: Tomasz KLOSOWIAK, et al.

JUL 1 2 2002

GAU:

2826

SERIAL NO: 09/911,444

EXAMINER: MONDT, J.P.

FILED:

July 25, 2001

STRUCTURE AND METHOD FOR FABRICATING SEMICONDUCTOR STRUCTURES AND DEVICES

FOR:

WITH OPTICAL PROCESSING LAYERS UTILIZING THE FORMATION OF A COMPLIANT

SUBSTRATE FOR MATERIALS USED TO FORM THE SAME

REQUEST FOR EXTENSION OF TIME UNDER 37 C.F.R. 1.136

ASSISTANT COMMISSIONER FOR PATENTS WASHINGTON, D.C. 20231

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iK:			
It is hereby requested that a three month extension of	time be granted to July 12, 2002 for		
☑ filing a response to the Official Action dated:	March 12, 2002.		
responding to the requirements in the Notice of Al			
☐ filing the Formal Drawings. The Issue Fee due has been timely		iled.	
responding to the Notice to File Missing Parts of A	Application dated:		
☐ filing a Notice of Appeal. A timely response to the final rejection, due		has been filed.	
☐ filing an Appeal Brief. A Notice of Appeal was fil	led on:	1 11 half	
☐ Applicant claims small entity status. See 37 CFR			
The required fee of \$920.00 is enclosed herewith by Record's Deposit Account No. 15-0030. A duplicate	check and any further charges may be ma copy of this sheet is enclosed.	de against the Attorney of	

Respectfully Submitted,

OBLON, PIVAK, McCLELLAND, MAYER & NEWSTADT, P.C.

Richard L. Treanor

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